

Mr. 220 924,404 <sup>in SPE</sup> *Br* *AT* *CP*

IN THE UNITED STATES PATENT OFFICE

In re application of Hyman Kirtchik  
Inv. No. 11,889  
Application Serial No. -  
Filed: Herewith  
For: LOW REFLECTANCE INFRARED CAMOUFLAGE SYSTEM

GROUP  
Examiner:

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

PRIOR ART STATEMENT UNDER 37 C.F.R. § 1.97

The applicant(s) wish to make of record the following prior art (with statement(s) of relevancy) which is/are believed to be the most relevant known to applicant(s) and/or the assignee concerning the invention as claimed in the above-identified application:

Prior Art Cited

3,614,188 [427-160-X]  
3,619,235 [350-1.7-X]  
3,682,528 [350-1.7]  
3,733,217 [350-1.7-X]  
3,816,271 [204-51]

Statement of Relevancy

Teaches use of germanium in infrared filters.  
Teaches that infrared reflecting layer may consist of metallic oxides.  
Teaches a plurality of layers as coating for countermeasure systems.  
Background information relative to countermeasure for heat seeking missiles.  
Background information relative to countermeasure for heat seeking missiles.

Copies of the above-identified prior art are enclosed herewith with copies of English translations of pertinent portions of any non-English language reference, if such translation was readily available.

The above cited prior art is not necessarily a complete listing of all prior art known to the applicant and/or the assignee. The listing only indicates that prior art which, in the reasonable opinion of the applicant and/or assignee, is the most relevant to the claimed invention.

Respectfully submitted,

24 July 1978

Date

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